

OCT 04 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

Inventor(s): Tue Nguyen, Tai Dung Nguyen
Appln. No.: 09/898,439
Confirm. No.: 1885
Filed: July 5, 2001
Title: PLASMA SEMICONDUCTOR PROCESSING
SYSTEM AND METHOD

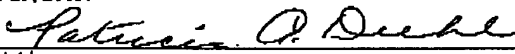
PATENT APPLICATION

Art Unit: 2818
Examiner: Quoc Dinh Hoang

Customer No. 23910

CERTIFICATE OF TRANSMISSION/MAILING

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the U.S. Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on December 29, 2005.


Patricia A. Diehl (Signature)
Signature Date: 10/14/06

REPLY TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is a response to the Office Communication of April 24, 2006. A Petition for Extension of Time is being submitted herewith to extend the response period to October 24, 2006. Since this date falls on a Sunday, the response date will be the following Monday, September 25, 2006. Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.